

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s):	William G. America, et al.	Examiner:	Jack S. J. Chen
Serial No:	10/674,646	Art Unit:	2813
Filed:	September 30, 2003	Docket:	YOR920030320US1 (16868)
For:	PLASMA SURFACE MODIFICATION AND PASSIVATION OF ORGANO- SILICATE GLASS FILMS FOR IMPROVED HARDMASK ADHESION AND OPTIMAL RIE PROCESSING	Dated:	June 29, 2007

Confirmation No. 4797

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Commissioner for Patents
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RESPONSE UNDER 37 C.F.R. § 1.116

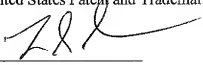
Sir:

In response to the Final Office Action dated April 4, 2007, and in accordance with the provisions of 37 C.F.R. §1.116, Applicants submit the following remarks for entry in the above-identified case.

CERTIFICATE OF ELECTRONIC FILING

I hereby certify that this correspondence is being deposited with the United States Patent & Trademark Office via Electronic Filing through the United States Patent and Trademark Office e-business website.

Dated: June 29, 2007



Leslie S. Szivos, Ph.D.